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FORM 1449* INFORMATION DISCLOSURE	INFORMATION DISCLOSURE STATEMENT		Application Number: 10/549494	
IN AN APPLICATION	Applicant: SASAK1 et al.			
(Use several sheets if necessary)		Filing Date: September 15, 2005	Group Art Unit: 1792	

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	Kawamura, Introduction pp. L-829-I,	et al., "Novel Li of the Flux Film 881, Part 2, No.	quid Phase Epitaxy (LPI n Coated-Liquid Phase E 8A 1 August 2003	E) Growth Metho pitaxy (FFC-LPI	d for Growing Large E) Method", Jpn. J. A	GaN Single C Appl. Phys. Vol	rystals: . 42 (2003

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\*Substitute Disclosure Statement Form (PTO-1449)

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